L Number	Hits	Search Text	DB	Time stamp
-	8	((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode).clm. and (black adj matrix).clm. and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:03
-	19	((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode) and (black adj matrix).clm. and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:03
-	3	((insulating or dielectric or insulation or oxide) adj substrate) same (transparent adj electrode) same (black adj matrix) same protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:05
-	3	(((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode) and (black adj matrix) and protrusion).ti,ab,clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:05
-	43	((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode) and (black adj matrix) and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:09
-	32	((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode) and (black adj matrix) and protrusion and ((transparent near electrode) near10 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:10
-	32	((insulating or dielectric or insulation or oxide) adj substrate) and (transparent adj electrode) and (black adj matrix) and protrusion and ((transparent adj electrode) near10 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:10
-	17059	((transparent adj electrode) near5 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:10
-	165	((transparent adj electrode) near5 substrate) and ((black near matrix) near5 (transparent adj electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:10
-	18	((transparent adj electrode) near5 substrate) and ((black near matrix) near5 (transparent adj electrode)) and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:16

-	10	((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)) and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:16
-	3	((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm. and protrusion	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:20
-	14	((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:25
-	1	(((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm.) and chrome	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:25
-	0	(((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm.) and phososensitive	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:25
-	5	(((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm.) and photosensitive	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/05 13:00
-	1	(((transparent adj electrode) near5 substrate).clm. and ((black near matrix) near5 (transparent adj electrode)).clm.) and photosensitive and (photolithography or lithography)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/04 16:27